



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No.: 1003-0610

Group Art Unit: 2812

Application of: Chiesl

Examiner: Viktor Simkovic

Serial No.: 09/960,441

Filed: September 21, 2001

For: **ARRANGEMENT FOR MEASURING PRESSURE ON A SEMICONDUCTOR WAFER AND AN ASSOCIATED METHOD FOR FABRICATING A SEMICONDUCTOR WAFER**

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PETITION FOR EXTENSION OF TIME

PURSUANT TO 37 C.F.R. § 1.136(a)

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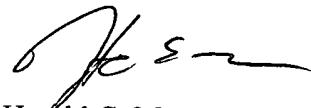
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Sir:

In connection with the Final Office Action mailed June 25, 2003 in the above-entitled patent application, Applicant respectfully requests a one (1) month extension in which to file a response, from September 25, 2003 to October 25, 2003.

The \$110.00 fee required by 37 C.F.R. § 1.136(a) is submitted herewith.

Respectfully Submitted,



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October 8, 2003
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